

05-07-2001



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## PATENTS RECORDATION COVER SHEET

To the Assistant Commissioner of Patents and Trademarks: Please record the attached original document or copy thereof.

1. Name of conveying party(ies):

Satoru ISOGAI

04/26/01

2. Name and Address of receiving party(ies):

NEC Corporation  
7-1, Shiba 5-chome, Minato-ku  
Tokyo, Japan

Type of Entity: Individual

Type of Entity: Corporation of Japan

Additional names(s) of conveying party(ies) attached? No

Additional name(s) &amp; address(es) attached? No

3. Nature of Conveyance:

Assignment

Execution Date: April 20, 2001

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is: April 20, 2001

A. Application No.(s)

09/842944

B. Patent No.(s)

Additional numbers attached? No

5. Name and address of party to whom correspondence concerning document should be mailed:

OSTROLENK, FABER, GERB & SOFFEN, LLP  
1180 Avenue of the Americas  
New York, New York 10036-8403

6. Total number of documents involved: 1

7. Total fee (37 CFR 3.41): \$ 40.00

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8. To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Steven I. Weisburd

Name of Person Signing

Signature

April 26, 2001

Date

Total number of pages including cover sheet, attachments, and document: 2

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PATENT  
REEL: 011755 FRAME: 0003

P/289-164 12.7423/00  
JE-1051-115  
T/110  
(通商特許)

WHEREAS, I (We), Satoru ISOGAI of Tokyo, Japan  
as assignor(s), have invented certain  
improvements in Semiconductor Device and Method of Fabricating Same  
for  
which an application for United States Letters Patent has been executed by me (us) of  
even date herewith; and

WHEREAS, NEC Corporation, 7-1, Shiba 5-chome, Minato-ku, Tokyo, Japan  
as assignee, is desirous of acquiring all right, title and interest in and to said  
invention and any Patent that may be granted therefor.

NOW, THEREFORE, in consideration of One Dollar (\$1.00) and other good and  
valuable consideration, the receipt of which is hereby acknowledged. I (We), as as-  
signor(s), hereby sell, assign and set over to said assignee the entire right, title  
and interest for the United States and all other countries in and to said invention  
and the aforesaid application for Patent, all original, divisional, continuation,  
substitute or reissue applications and patents applied for or granted therefor in the  
United States and all other countries, including all rights of priority from the fil-  
ing of said application, and all rights for past infringement, and the Commissioner  
of Patents and Trademarks is hereby authorized and requested to issue all patents on  
said inventions or resulting therefrom to said assignee herein, as assignee of the  
entire interest therein; and the undersigned for myself (ourselves) and my (our)  
legal representatives, heirs and assigns do hereby agree and covenant without further  
remuneration, to execute and deliver all divisional, continuation, reissue and other  
applications for Patent on said inventions and all assignments thereof to said  
assignee or its assigns, to communicate to said assignee or its representatives all  
facts known to the undersigned respecting said inventions, whenever requested, to  
testify in any interferences or other legal proceedings in which any of said applica-  
tions or patents may become involved, to sign all lawful papers, make all rightful  
oaths, and to do generally everything necessary to assist assignee, its successors,  
assigns and nominees to obtain patent protection for said invention in the United  
States and all other countries, the expenses incident to said applications to be  
borne and paid by said assignee.

Date: April 20, 2001

Satoru Isogai (印)  
Satoru ISOGAI

Date: \_\_\_\_\_

Witness:

Date: April 20, 2001

Nitoshiki Utsunomiya

Date: April 20, 2001

Atsuo Muro

Date: \_\_\_\_\_

Date: \_\_\_\_\_

Date: \_\_\_\_\_

Date: \_\_\_\_\_

Date: \_\_\_\_\_